

Notice of References Cited		Application/Control No. 10/533,420	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
		Examiner Yelena G. Gakh, Ph.D.	Art Unit 1797	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0048610	04-2002	Cima et al.	424/725
*	B	US-2003/0116497	06-2003	Carlson et al.	210/435
	C	US-			
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	F	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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